

## 中文核心期刊

## Chinese Journal of Liquid Crystals and Displays

主管:中国科学院 主办:中国科学院长春光学精密机械与物理研究所

中国物理学会液晶分会

中国光学光电子行业协会液晶分会

主编:郭海成

首 页 | 期刊介绍 | 编委会 | 投稿指南 | 期刊订阅 | 数据库收录 | 联系我们 | English

液晶与显示 2013, 28(2) 204-209 ISSN: CN:

本期目录 | 下期目录 | 过刊浏览 | 高级检索

[打印本页] [关闭]

器件物理及器件制备技术

TFT-LCD Touch Mura不良的研究和改善

齐鹏1,2 施园2 刘子源2

- 1. 清华大学 电子工程系,北京 100084;
- 2. 合肥京东方光电科技有限公司,安徽 合肥 230012

摘要: Touch Mura在整个TFT-LCD制作流程中非常容易发生,并且严重影响产品性能。文章主要研究了液晶量、Sub PS设计、PS段差设计及工艺参数Total pitch对Touch Mura的影响。实验结果表明液晶量的增加能够补偿敲击偏移,减轻Touch Mura不良;Sub PS的Z字形设计由于阻挡效应能够有效减轻Touch Mura;Main PS和Sub PS的段差越大,Touch Mura margin越小;工艺参数Total Pitch越接近设计值,Touch Mura风险越小。所以在设计过程中优化液晶量和Main-Sub PS段差设计及Sub PS设计能够有效减低Touch Mura风险,此外,生产过程中对工艺参数Total pitch的管控也至关重要。

关键词: Touch Mura 液晶量 柱状隔垫物 Total Pitch

Research and Improvement of Touch Mura in TFT-LCD

QI Peng<sup>1,2</sup>, SHI Yuan<sup>2</sup>, LIU Zi-yuan<sup>2</sup>

- 1. Department of Electronic Engineering, Tsinghua University, Beijing 100084, China;
- 2. Hefei BOE Optoelectronics Technology Co. Ltd, Hefei 230012, China

Abstract: Nowadays, much attention had been paid to the investigation of Touch Mura, which affects the performance of products seriously. It has been observed frequently during the manufacturing process of TFT-LCD products. In this paper, several important impact factors to the Touch Mura were systematically studied, including the liquid-crystal quantity, the designing of sub PS, the designing of height difference between main PS and sub PS, and the total pitch (one of the process parameters). The experiment results demonstrated that the increment of liquid-crystal quantity can compensate the touch shift; thereby the decrease of the defect rates in Touch Mura will be lead to a certain extent. The "Z" design of sub PS can ease the Touch Mura effectively due to the blocking effect. Besides, it was also found that the more height difference between main PS and sub PS, the smaller Touch Mura margin is; meanwhile, if it set the parameter of total pitch close to the design values, the Touch Mura will occur in a very little chance. In conclusion, in order to reduce the risk of Touch Mura, it can obey the following ways in the new frame, including the proper using liquid-crystal quantity, the optimum designing of sub-PS, and the metering the height difference between the main and sub PS. In addition, the controlling of total pitch is also of great importance in manufacturing process.

Keywords: touch Mura liquid crystal amount post spacer total pitch

收稿日期 2012-09-03 修回日期 2012-09-11 网络版发布日期

基金项目:

通讯作者:

作者简介: 齐鹏(1983-),男,河北故城人,硕士研究生,高级工程师,主要从事TFT-LCD产品的品质管理工作,E-mail: qipeng@boe.com.cn。作者Email:

## 参考文献:

[1] 吴洪江,王威,龙春平.一种TFT LCD vertical Block Mura的研究与改善[J].液晶与显示,2007,22(4):433-439. [2] 张卓,赵海玉,张培林,等.基于重压法的Touch mura形变过程模拟 [J].液晶与显示,2010,25(5):693-695. [3] 毛学军.液晶显示技术 [M]. 北京:电子工业出版社,2008:6-69. [4] 李雄杰.平板电视技术[M]. 北京:电子工业出版社,2007:40-79. [5] [日]堀 浩雄 铃木幸治[M]. 第二版. 北京:科学出版社,2006:92-124. [6] 戴亚翔.TFT-LCD面板的驱动与设计[M]. 北京:清华大学出版社,2008:1-82. [7] 张卓,柳在健,侯延冰.液晶量对Touch mura的影响[J].液晶与显示,2008,23(5):525-529. [8] 杨国波,王永茂,王向楠,等.ODF工艺中液晶滴下量的优化 [J]. 液晶与显示,2011,26(3):324-328. [9] 程石,王涛,张敏,等.TFT-LCD中隔垫物密度与Push mura和低温气泡的关系 [J]. 液晶与显示,2011,26(5):604-607. [10] 于涛,陈晟,储培鸣,等.新型TFT-LCD柱状隔垫物的形变研究 [J]. 液晶与显示,2012,27(4):445-447.

本刊中的类似文章

- 1. 靳福江, 王在清, 范峻, 刘阳升, 曾望明. 含有柱状隔垫物彩膜基板的剥离技术[J]. 液晶与显示, 2013,28(2): 220-223
- 2. 于涛, 陈晟, 储培鸣, 郑永亮, 申剑锋.新型TFT-LCD柱状隔垫物的形变研究[J]. 液晶与显示, 2012, (4): 445-447
- 3. 张卓, 赵海玉, 张培林, 柳在健,基于重压法的Touch Mura形变过程模拟[J]. 液晶与显示, 2010,25(5): 693-695
- 4. 齐鹏 施园 刘子源.TFT-LCD Touch Mura不良的研究和改善[J]. 液晶与显示, ,(): 0-0

Copyright by 液晶与显示